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SCREEN Completes New Factory S³-4 for Semiconductor Production Equipment

Kyoto, Japan – January 30, 2023 – SCREEN Holdings Co., Ltd. has finalized construction of S³-4 (S-Cube 4), its new factory specifically designed for semiconductor production equipment. Work on the facility had been continuing at the SCREEN's existing Hikone Site since January, 2022.



S³-4 (S-Cube 4)

Please download the photo from:
www.screen.co.jp/en/about/nr-photo_2023

Overview of New Factory

Name:	S ³ -4 (S-Cube 4) (S ³ stands for Safety, Smart, Speed)
Location:	480-1 Takamiya-cho, Hikone, Shiga, Japan
Building area:	Approx. 5,285 m ²
Total floor area:	Approx. 9,625 m ²
Construction type:	Two story, steel frame building
Total cost:	Approx. 10 billion yen (total amount for the current facility investment)
Operation start:	January 2023
Main business:	Production of single wafer cleaning equipment, and so on.

- Related news release (Announced on January 28, 2022)
SCREEN Takes Next Step in Strengthening Its Manufacturing System for Semiconductor Production Equipment
-New Factory Scheduled to Begin Operation in January 2023-
URL : www.screen.co.jp/en/news/NR220128-1E